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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE (Attorney Docket No. 100176)

First Inventor: Roland K. Sevilla

Serial No.: 10/601,601 Filing Date: 06/23/2003

Title: POLISHING PAD FOR

ELECTROCHEMICAL-MECHANICAL POLISHING

Examiner: Maurina T. Rachuba

Art Unit:

3723

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Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

## RESPONSE TO OFFICE ACTION

This is a reply to the Office Communication mailed November 1, 2006 for the above captioned U.S. patent application.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

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